



IN THE U.S. PATENT AND TRADEMARK OFFICE

April 20, 2009

Applicants: Atsushi YABE et al

For: ELECTROLESS COPPER PLATING SOLUTION

Serial No.: 10/576 231 Group: 1792

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Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

LETTER TO PATENT OFFICE

Sir:

Further to the Request for Continued Examination filed February 20, 2009, Applicants are enclosing herewith a Declaration Under 37 CFR 1.132 in which additional tests are performed that illustrate the importance of the water-soluble nitrogen-containing polymer being present in the electroless copper plating solution of the present invention. In order to show that the presently claimed invention is not limited to polyethylene amine and polyacrylamide as the water-soluble nitrogen-containing polymer as it uses polyvinyl pyrrolidone as the water-soluble nitrogen-containing polymer and produces excellent results. Example 8 in the enclosed Declaration shows that the electroless copper plating solution can be used to deposit copper on substrates other than a silicon wafer having a tantalum nitride film and still produce excellent results.

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Reconsideration of the present application is respectfully solicited.

Respectfully submitted,

Terryence F. Chapman

TFC/smd

FLYNN, THIEL, BOUTELL.	David G. Boutell	Reg.	No.	25	072
& TANIS, P.C.	Terryence F. Chapman	Reg.	No.	32	549
2026 Rambling Road	Mark L. Maki	Reg.	No.	36	589
Kalamazoo, MI 49008-1631	Liane L. Churney	Reg.	No.	40	694°
Phone: (269) 381-1156	Brian R. Tumm	Reg.	No.	36	328
Fax: (269) 381-5465	Donald J. Wallace	Reg.	No.	43	977
	Dale H. Thiel	Reg.	No.	24	323
	Sidney B. Williams, Jr.	Reg.	No.	24	949
	Heon Jekal	Reg.	No.	L0379*	
	*limited recognition number				

Encl: Declaration Under 37 CFR 1.132
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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April 20, 2009.

Terryence F. Chapman

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